

ABSTRACT OF THE DISCLOSURE

A substrate is placed on a Y-axis movement table, and a syringe containing paste is rendered capable of applying paste while moving in an 5 X-axis direction on a head mechanism. Since the head mechanism provided with the syringe is rendered movable in the Y-axis direction by the Y-axis movement mechanism, a distance of movement of the syringe containing paste in the Y-axis direction is reduced, and a mechanical load on the head mechanism is reduced as well. Accordingly, production of metal dust 10 attributable to abrasions and the like are suppressed, and it is possible to achieve high-quality and efficient paste pattern formation.